

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:  
Shinji MAEKAWA et al.  
Serial No.: 10/827,457  
Filed: April 19, 2004  
For: Method For Forming Pattern And  
Drop Discharge Apparatus  
Examiner: Marianne L. Padgett  
Art Unit: 1792  
Confirmation No.: 2984

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT G**

Applicants have the following response to the Office Action of December 19, 2008.

Please amend the above-identified application as follows: